

Docket No. 219387US2S/shb

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: Hiroshi ITO

SERIAL NO: 10/067,309

GAU: 1741

FILED: February 7, 2002

EXAMINER:

FOR: LASER PROCESSING METHOD AND APPARATUS

INFORMATION DISCLOSURE/RELATED CASE STATEMENT UNDER 37 CFR 1.97

ASSISTANT COMMISSIONER FOR PATENTS
WASHINGTON, D.C. 20231

SIR:

Applicant(s) wish to disclose the following information.

REFERENCES

- ☒ The applicant(s) wish to make of record the references listed on the attached form PTO-1449. Copies of the listed references are attached, where required, as are either statements of relevancy or any readily available English translations of pertinent portions of any non-English language references.
- ☐ A check is attached in the amount required under 37 CFR §1.17(p).

RELATED CASES

- ☐ Attached is a list of applicant's pending application(s) or issued patent(s) which may be related to the present application. A copy of the patent(s), together with a copy of the claims and drawings of the pending application(s) is attached along with PTO 1449.
- ☐ A check is attached in the amount required under 37 CFR §1.17(p).

CERTIFICATION

- ☐ Each item of information contained in this information disclosure statement was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this statement.
- ☐ No item of information contained in this information disclosure statement was cited in a communication from a foreign patent office in a counterpart foreign application or, to the knowledge of the undersigned, having made reasonable inquiry, was known to any individual designated in 37 CFR §1.56(c) more than three months prior to the filing of this statement.

DEPOSIT ACCOUNT

- ☒ Please charge any additional fees for the papers being filed herewith and for which no check is enclosed herewith, or credit any overpayment to deposit account number 15-0030. A duplicate copy of this sheet is enclosed.

Respectfully submitted,

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Group Art Unit: 1741

STATEMENT OF RELEVANCY

Reference AO (JP 56-137546) on Form 1449:

This reference is discussed in the specification.

Reference AO (JP 58-39012) on Form 1449:

In this reference, a shaped line beam delivered from a continuous mode laser is used for crystallization of Si film which contains some large grains, but in the present application, patterned several line beams delivered from a pulse mode laser are used for crystallization with high through put.

Reference AQ (JP 2000-505241)on Form 1449:

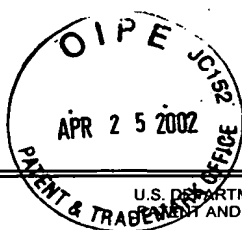
In this reference, a shaped line beam delivered from a pulse mode laser is used for crystallization of poly Si film with a micro step beam scanning, bat in the present application, patterned several line beams demonstrate high through put process.

This reference is discussed in the specification.

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Form PTO 1449 (Modified)		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY DOCKET NO. 219387US2S		SERIAL NO. 10/067,309	
LIST OF REFERENCES CITED BY APPLICANT				APPLICANT Hiroshi ITO			
				FILING DATE February 7, 2002		GROUP 1741	
U.S. PATENT DOCUMENTS							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FILING DATE IF APPROPRIATE
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						
	AL						
	AM						
	AN						
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	TRANSLATION YES NO		
	AO	56-137546	10/27/81	JAPAN			X
	AP	58-39012	03/07/83	JAPAN			X
	AQ	3-204986 (2000-505241)	09/04/2001	JAPAN			X
	AR						
	AS						
	AT						
	AU						
OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, etc.)							
	AV						
	AW						
	AX						
	AY						
	AZ						
Examiner					Date Considered		
*Examiner: Initial if reference is considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							

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